

FIG. 1

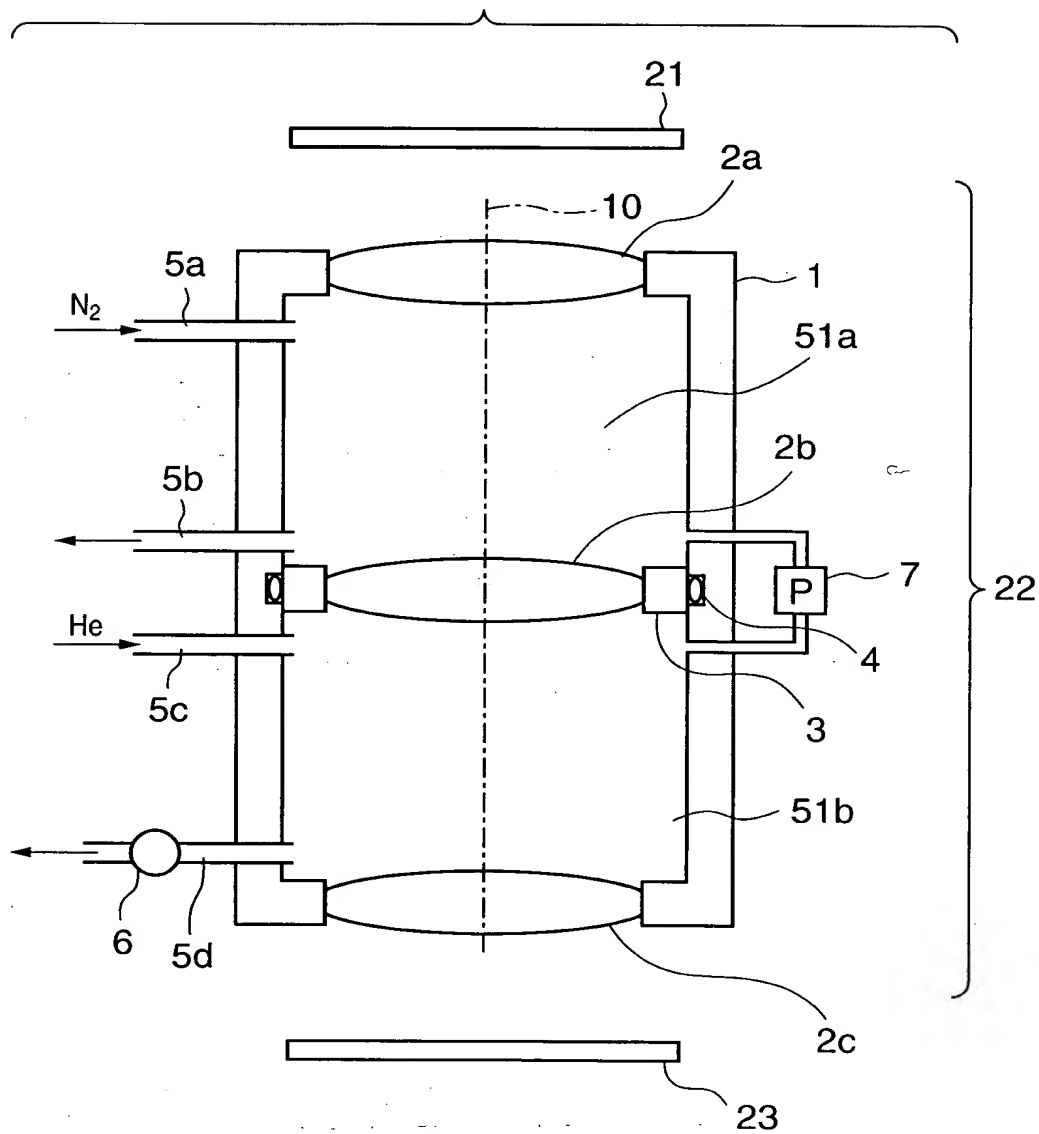


FIG. 2

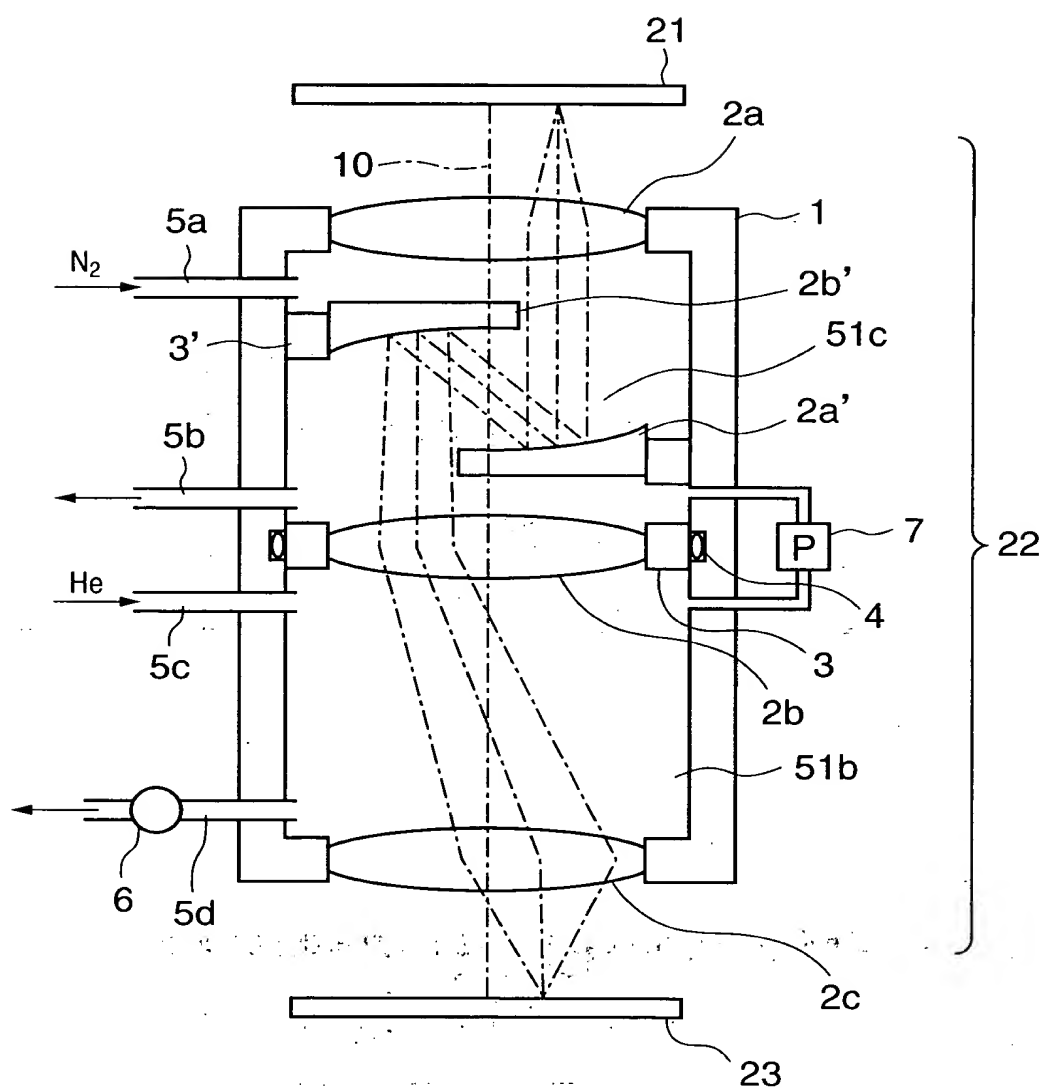
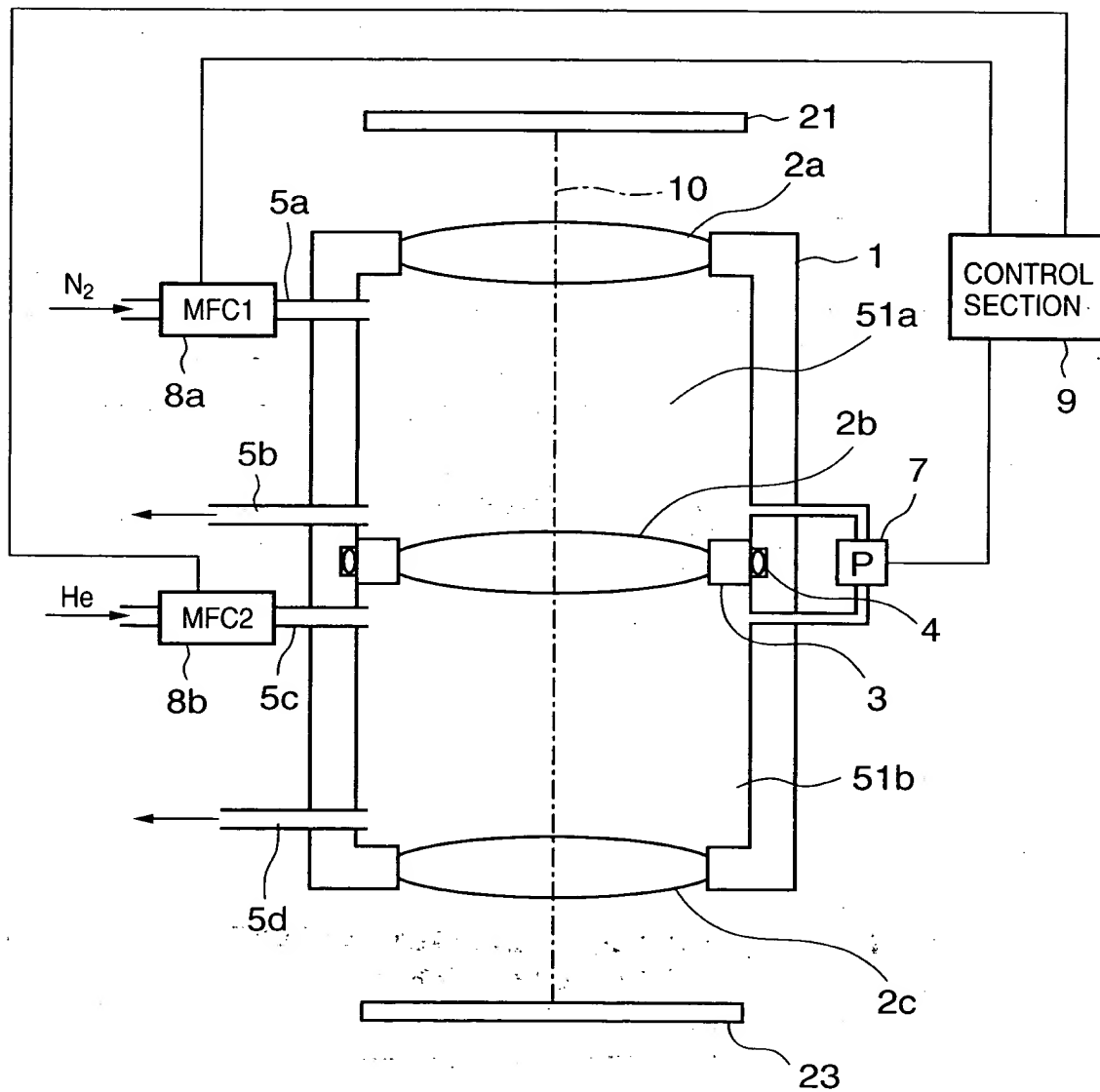


FIG. 3



T02080" 0586T660

FIG. 4

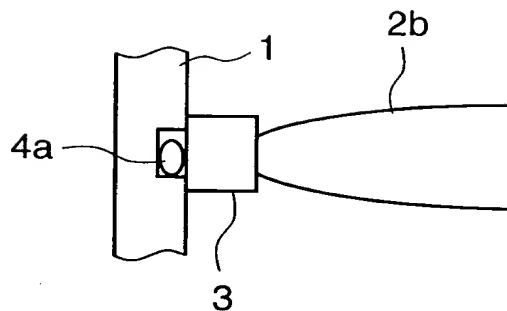


FIG. 5

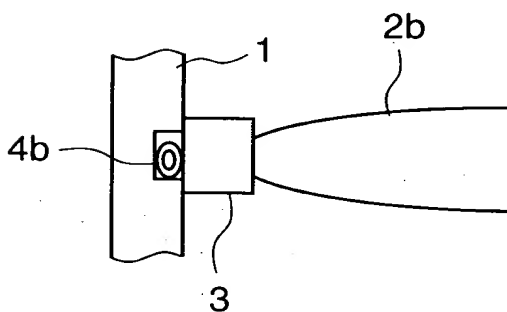


FIG. 6

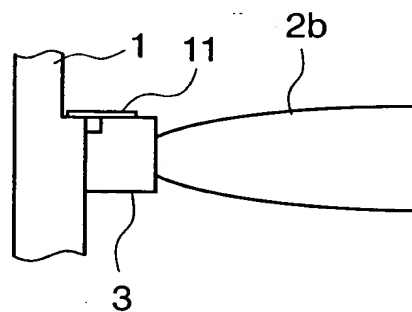


FIG. 7

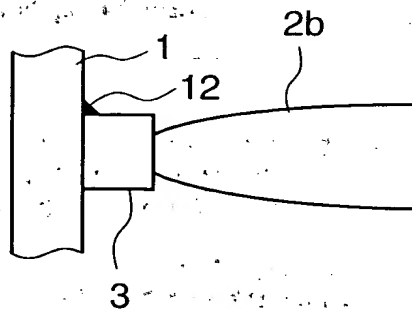


FIG. 8

AIR CONCENTRATION CHANGE IN He SPACE WITH
RESPECT TO PRESSURE DIFFERENCE BETWEEN SPACES

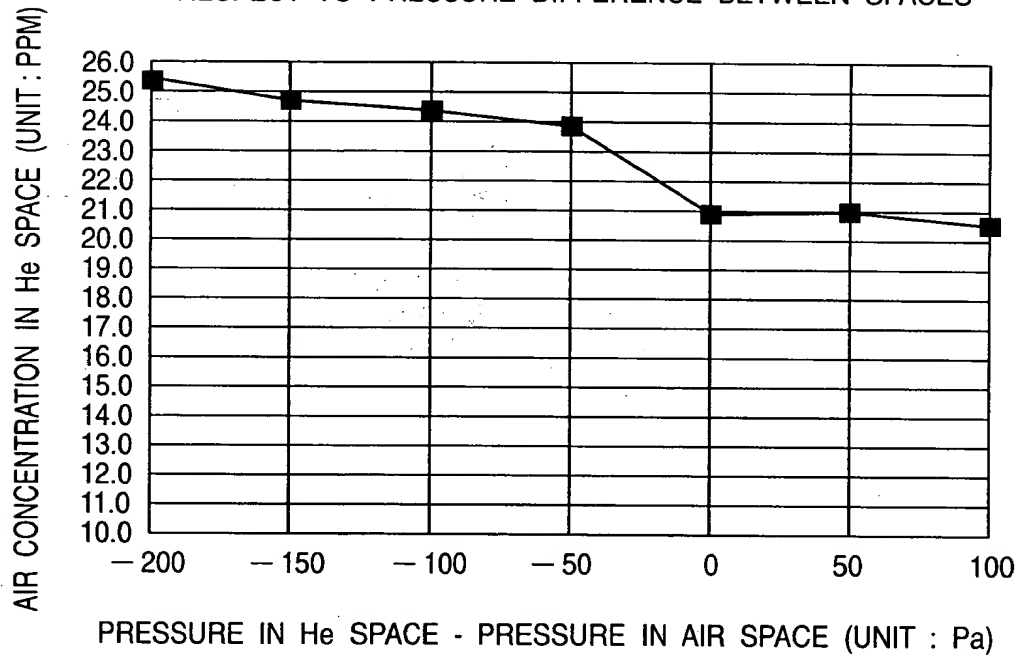
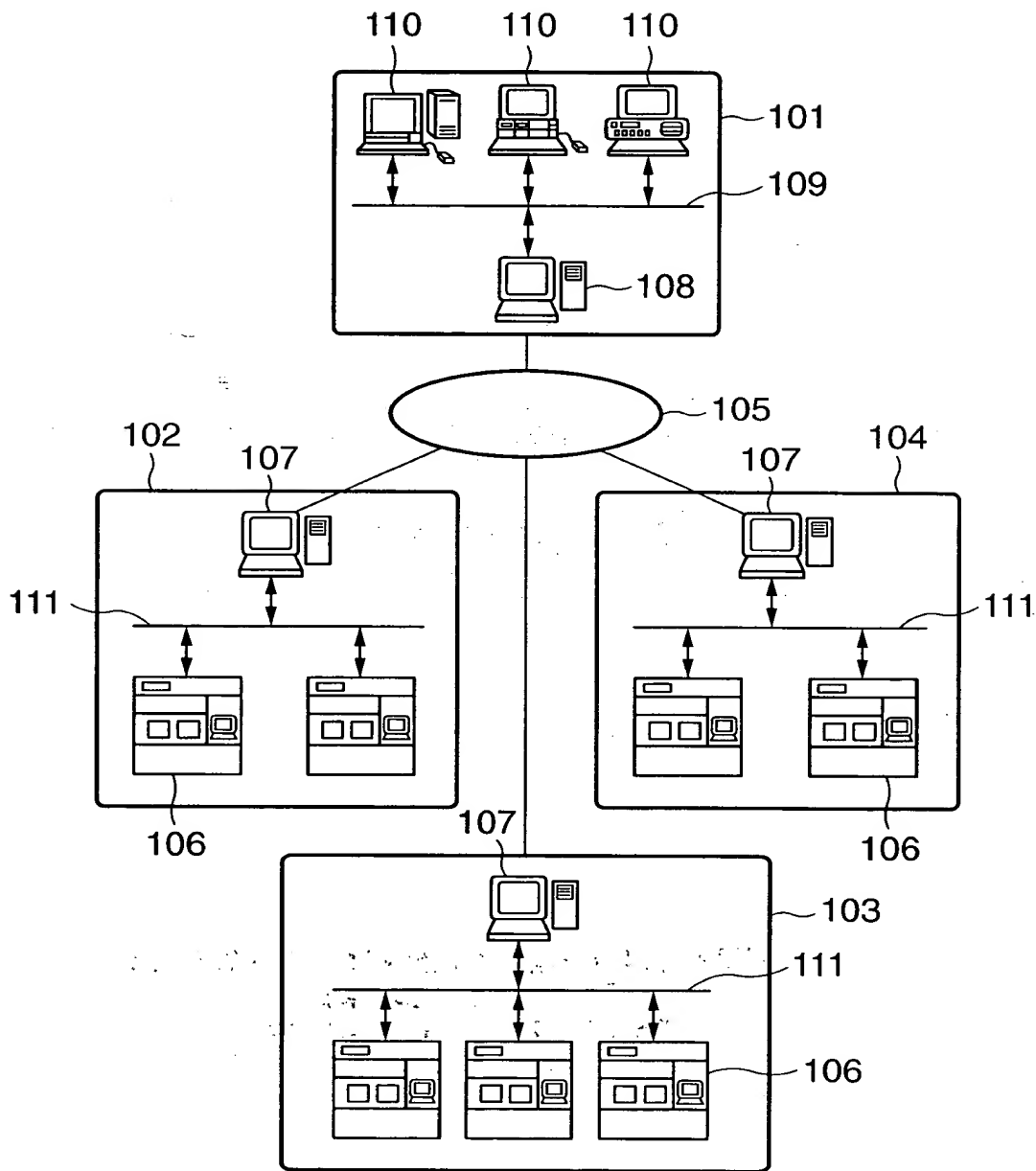


FIG. 9



102080" 05861660

FIG. 10

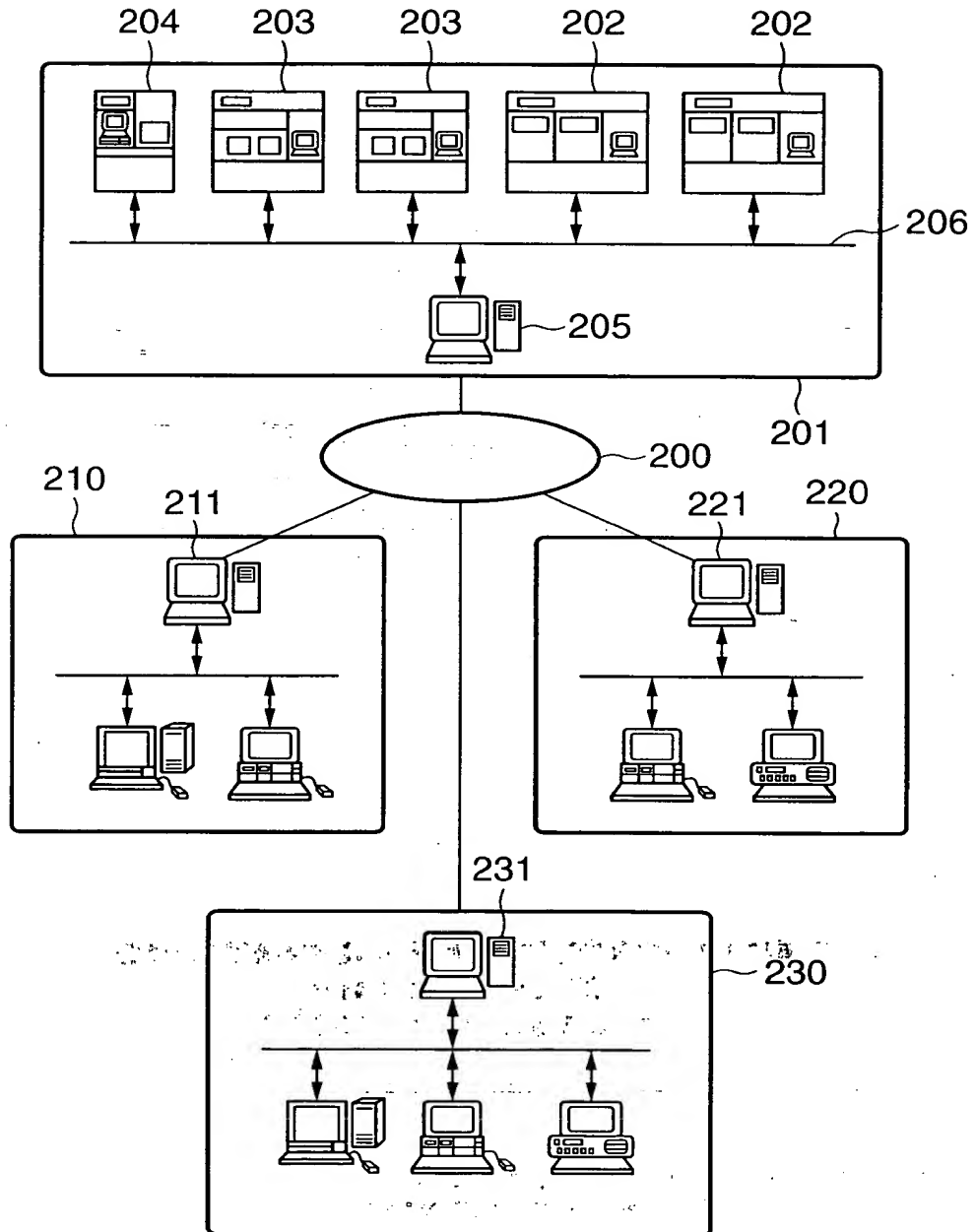


FIG. 11

URL

TROUBLE DB INPUT WINDOW

OCCURRENCE DATE ~ 404

TYPE OF APPARATUS ~ 401

SUBJECT ~ 403

SERIAL NUMBER S/N ~ 402

DEGREE OF URGENCY ~ 405

SYMPTOM ~ 406

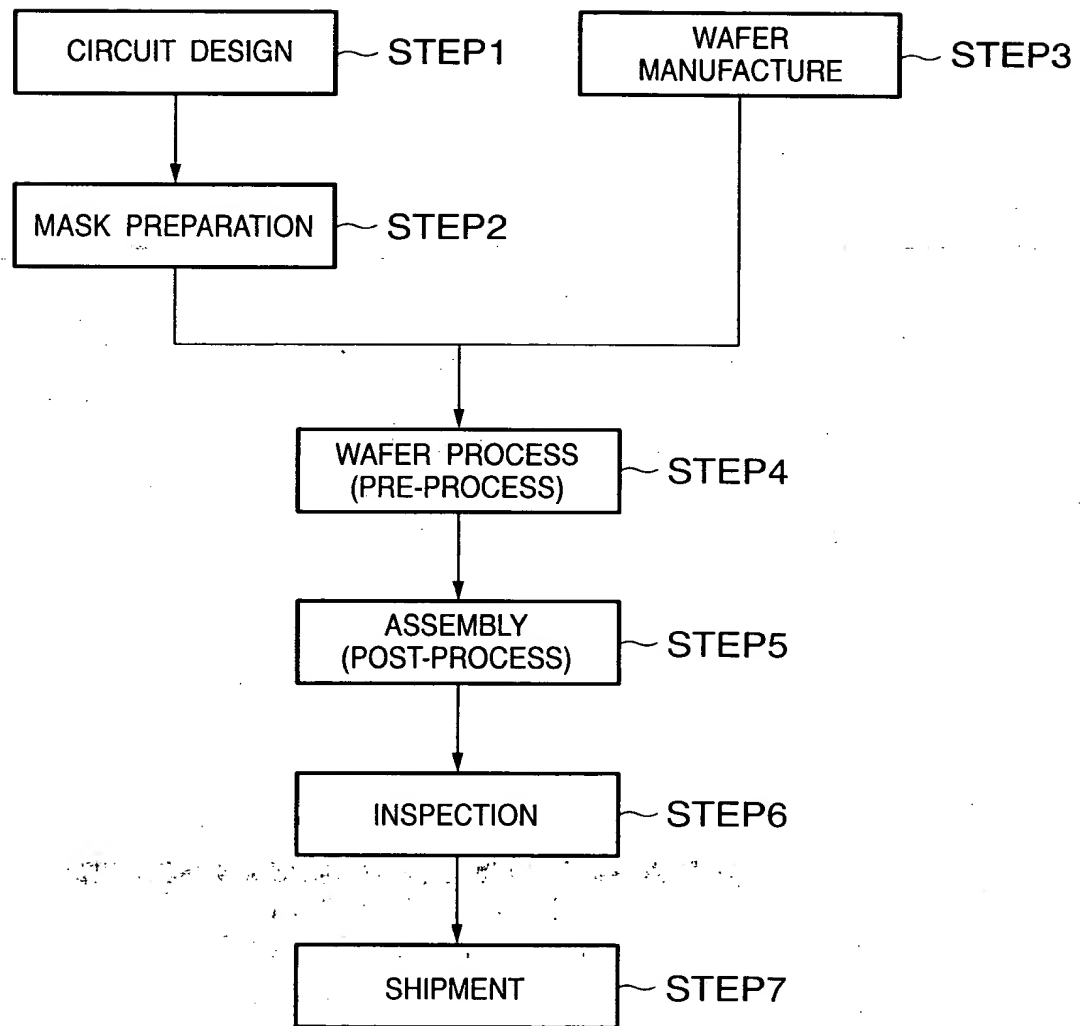
REMEDY ~ 407

PROGRESS ~ 408

410 411 412

[LINK TO RESULT LIST DATABASE](#) [SOFTWARE LIBRARY](#) [OPERATION GUIDE](#)

102080" 0586T 650

FIG. 12

SEMICONDUCTOR DEVICE MANUFACTURING FLOW

TOP SECRET 0586T650

FIG. 13

